



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Kamal Kishore Goundar

(as amended)

Appl. No.

10/722,179

Filed

November 25, 2003

For

METHOD OF

MANUFACTURING SILICON

CARBIDE FILM

Examiner

Igwe U Anya

Group Art Unit

2825

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 8, 2005

(Date)

Katsuhiro Arai, Reg. No. 43,315

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed January 3, 2005, please reconsider the present application in light of the following amendments and comments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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